

SEP 06 2005

Docket No. 740756-2670

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Patent Application of: |) |
| Shinji MAEKAWA et al. |) Group Art Unit: 2813 |
| Application No. 10/713,219 |) Examiner: Laura M Shillinger |
| Filed: November 17, 2003 |) Confirmation No.: 2735 |
| For: METHOD FOR FABRICATING THIN FILM TRANSISTOR |) Date: September 6, 2005 |
| |) |

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

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Signature: _____

Name: _____

AMENDMENT

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed May 3, 2005, please amend the above-identified application as follows:

W673076.1